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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re application of : **Confirmati n No. 4423**
Tomohiro OKUMURA et al. : Docket No. 2001_1089A
Serial No. 09/918,823 : Group Art Unit 2821
Filed August 1, 2001 : Examiner T. Phan

PLASMA PROCESSING METHOD
AND APPARATUS THEREOF

PETITION FOR EXTENSION OF TIME

Assistant Commissioner for Patents,
Washington, DC 20231

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

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Sir:

Petition hereby is made for a three month extension of time to respond to the communication of August 28, 2002.

The fee of \$930.00 is

- ☒ submitted herewith.
☐ to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is enclosed.
☐ Small entity status of this application is established by a Small Entity Status Assertion which
☐ is enclosed.
☐ has been previously submitted.

Respectfully submitted,

Tomohiro OKUMURA et al.

By

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February 28, 2003

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